G4CMP-317 Validation

Michael Kelsey, Wade Lamberson, and Nolan Tenpas

DMC Working Group Meeting

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Validation Process

Low Level Validation: Does the algorithm do what we are expecting it to do?

- What is the algorithm doing?
- Where do phonons fail (diffuse fallback)? Why does this happen?

High Level Validation: Does the algorithm give expected macroscopic results?

- Test detector with a 10keV Bulk NR deposit
- Run this detector with 3 orientations: unchanged, rotated, and displaced

Internal Settings: What is the step size and step limit that gives the best results?

Parameter Tuning (not discussed here): Determining the correct probability of diffuse vs specular reflections to better match detector data

Low Level Validation

Sample Information

Sim Information:

Software Information:

Total Events = 1

G4CMP : G4CMP-461

Energy Deposit = 10 keV

Geant4: geant4-10-07-patch-04 [MT]

Deposit Type = (0,0,0) NR

ROOT: 6.28/12

100% Specular Reflections

SuperSim: elog/2117-2-g4003271f

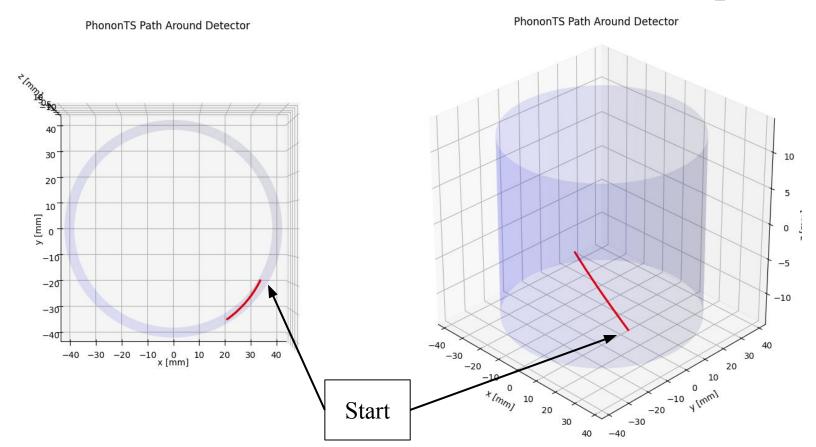
QET Abs = 100%

TES Subgap Abs = 100%

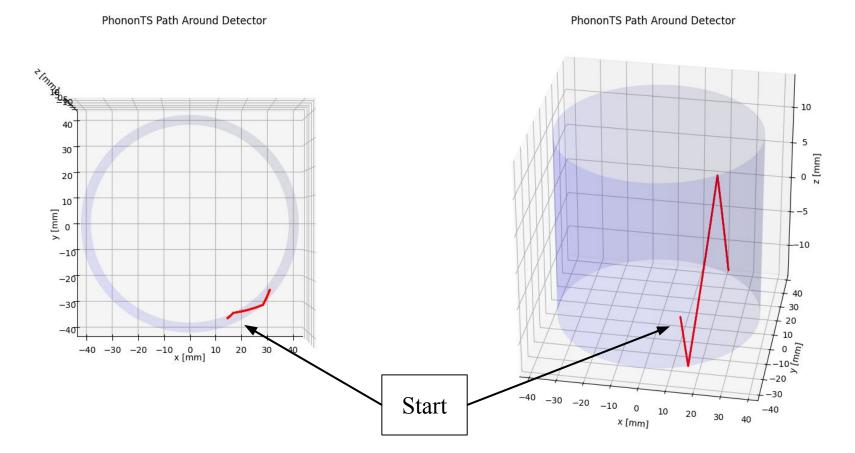
Detector Used:

Single Detector = iZIP5

Individual Phonon - Path Around Detector (Simple)



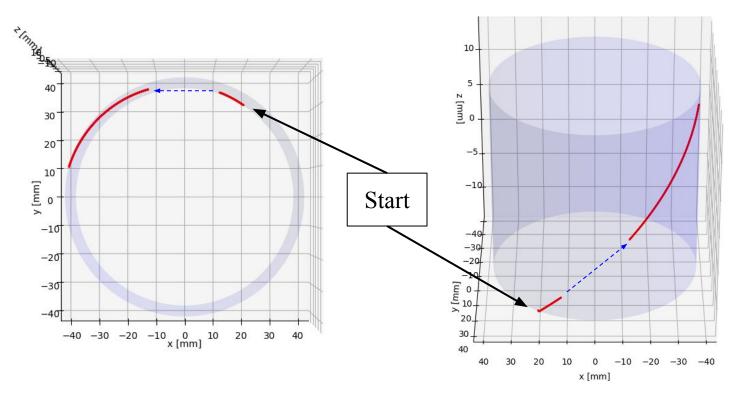
Individual Phonon - Path Around Detector (Edge Reflection)



Individual Phonon - Path Around Detector (Skip Flats)

PhononTS Path Around Detector

PhononTS Path Around Detector

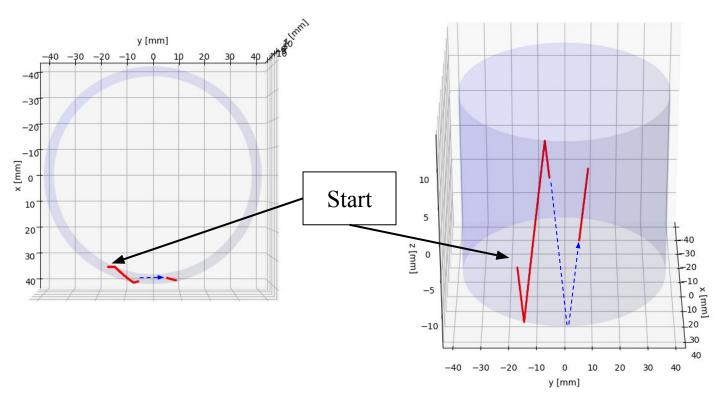


These are scatter plots - The gap is due to the displacement across the flat taking 0 steps

Individual Phonon - Path Around Detector (Skip Flats + Edge Reflection)

PhononTS Path Around Detector

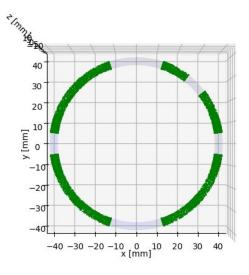
PhononTS Path Around Detector



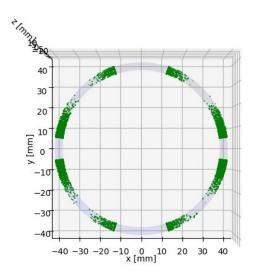
These are scatter plots - The gap is due to the displacement across the flat taking 0 steps

Plotting Successful Reflection Locations

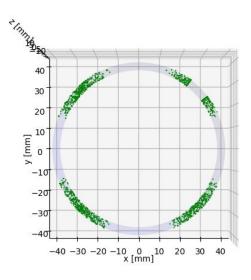
PhononTS Successful Reflections Position Distribution G4CMP-317



PhononTF Successful Reflections Position Distribution G4CMP-317

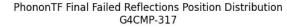


PhononL Successful Reflections Position Distribution G4CMP-317

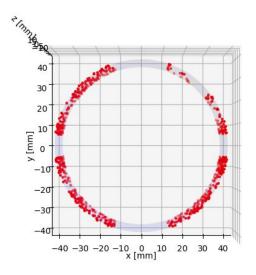


Plotting Diffuse Reflection Locations

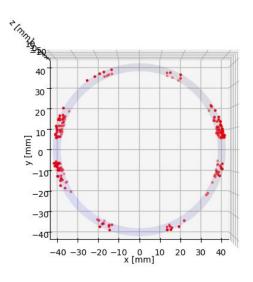
PhononTS Final Failed Reflections Position Distribution G4CMP-317



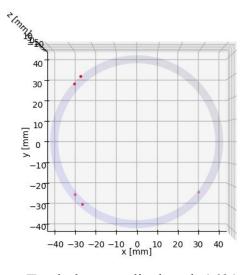
PhononL Final Failed Reflections Position Distribution G4CMP-317



Total phonons displaced: 19290 Failed reflections on walls: 633



Total phonons displaced: 9950 Failed reflections on walls: 193

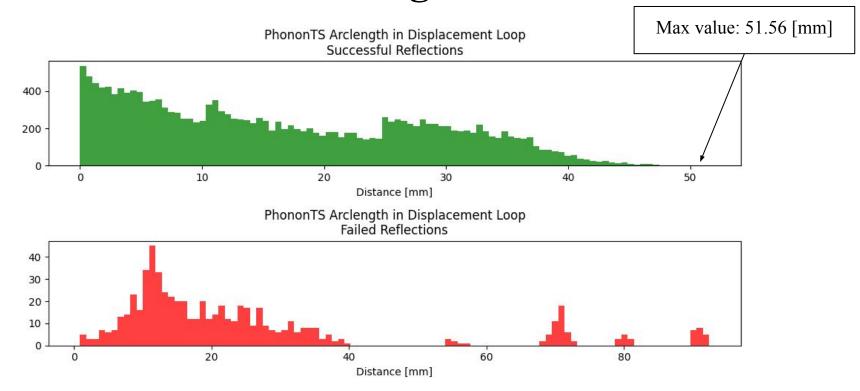


Total phonons displaced: 1691 Failed reflections on walls: 5

Total Displaced Reflections: 30931; Total Diffuse Reflections: 838

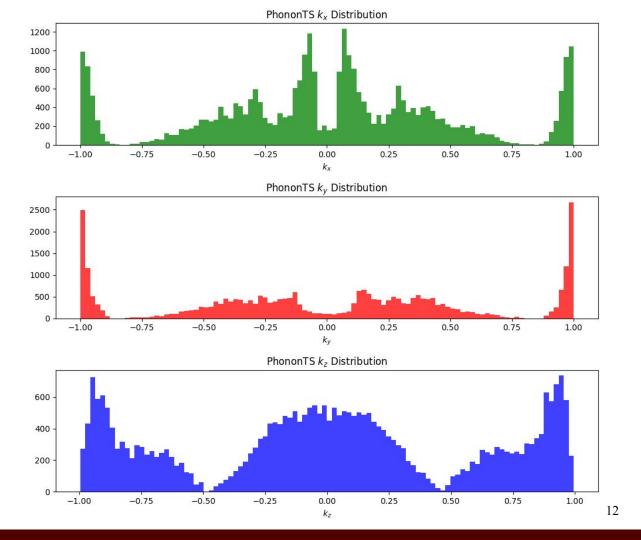
- \rightarrow 2.7% Displaced phonons ended up diffuse
 - → 7 phonons didn't reach 1000 steps

Slow-Transverse Arc Length Traveled



 \rightarrow 551 failed reflections have arc length < 40mm

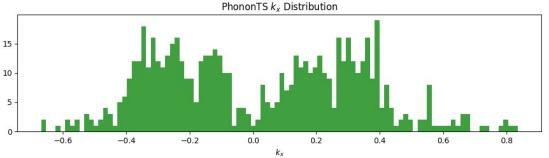
Slow-Transverse Wave Vector Distribution Successful Reflections

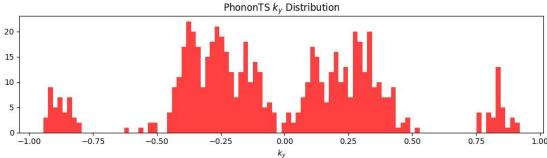


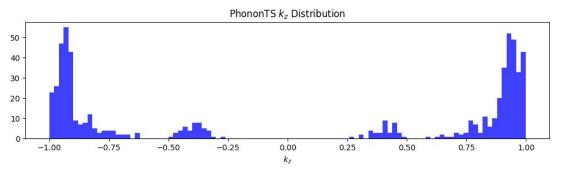
Slow-Transverse Wave Vector Distribution - Faile Reflections

This means a majority of failures are bouncing back and forth between the top and bottom Z faces, and not moving far enough azimuthally to get an inward group velocity

This can be handled by increasing the number of steps taken (see Internal Settings)







Low Level Validation: Notes and Observations

The code is doing what we expect it to do!

As shown in the previous slides, we see that the phonons are successfully stepping along the curved sidewall, reflecting as needed against the Z surfaces

We have seen phonons enter onto the detector flat and "skip" across it; maintaining the expected k-tangent trajectory, handling the reflections against the Z surfaces as needed

The remaining diffuse reflections are due to phonons with a large k_Z component, which cause the phonons to bounce between the Z surfaces instead of moving a sufficient angular distance to find an inward group velocity

- This can be further reduced by adjusting the internal displacement loop settings (shown in the <u>Internal Settings</u> section)

High Level Validation

Sample Information

Sim Information:

Total Events = 1

Energy Deposit = 10 keV

Deposit Type = Bulk NR

100% Specular Reflections

QET Abs = 100%

TES Subgap Abs = 100%

Autoseed off

Detectors Used:

Single Detector = HV100mm

Software Information:

G4CMP: G4CMP-480

Geant4: geant4-10-07-patch-04 [MT]

ROOT: 6.28/12

SuperSim: elog/2117-2-g4003271f

Results

Detector Orientation	Number of Diffuse Reflections
Normal	1033
Rotated (120 degree)	991
Displaced (.5 .5 .5 m)	1023
Rotated (120 degree) & Displaced (.5 .5 .5 m)	974

All events had 100% collection efficiency

Differences between the rotated and unrotated simulations are likely due to numerical errors by applying repetitive transforms

High Level Validation: Notes and Observations

Overall, things look very good. We have thoroughly tested this branch with several phonon burst jobs, each with 100% collection efficiency

- We no longer have the killed phonon messages from before this work (<u>G4CMP-310</u>)
- The displaced phonons have the correct volume assignment and don't escape to the world

We believe that the differences between the normal and rotated detector jobs are due to numerical inaccuracies. If the same phonon enters the displacement loop with a slightly different position or wavevector, this difference will compound on itself as the phonon bounces around

When running single phonon jobs, we saw very little differences for ~ 30 steps between the normal and rotated detector. At 30 steps, the X position was different by a little more than 1pm. This difference gradually grew as the phonon bounced around. Details have been described in G4CMP-480

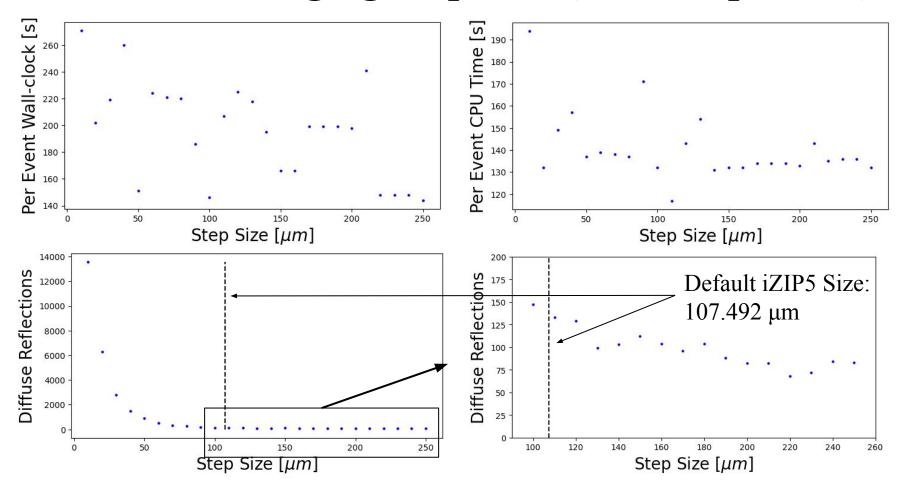
Internal Settings

What are the Internal Settings?

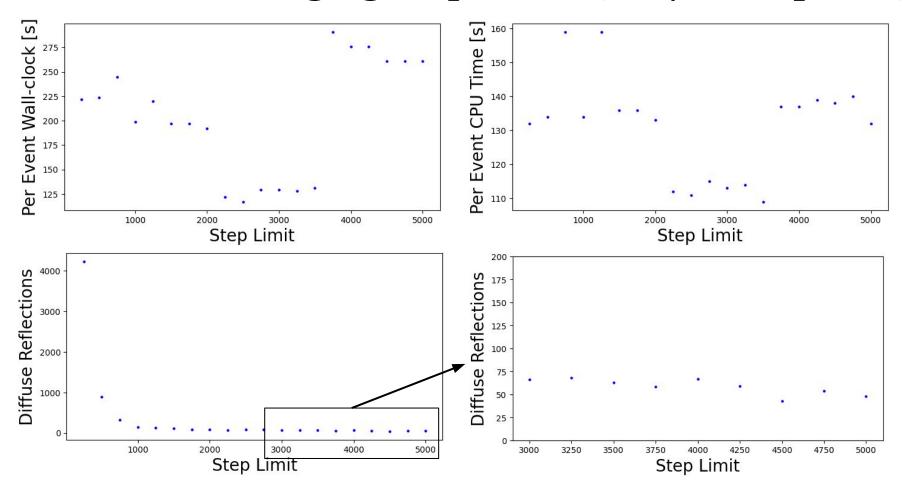
In this model, we use two settings to "tune" the algorithm to reduce the number of diffuse reflection fallbacks:

- 1) **Step Size** The linear distance displaced (prior to surface adjustment) while stepping around the detector
 - a) Set with the macro command: /g4cmp/phononSurfStepSize N <unit>
 - b) Default value: (Diagonal distance of the solid bounding box) / 1000
- 2) **Step Limit** The number of steps taken around the detector until we use the diffuse fallback
 - a) Set with the macro command: /g4cmp/phononSurfStepLimit N
 - b) Default value: 5000

Results - Changing Step Size (1000 Step Limit)



Results - Changing Step Limit (100µm Step Size)



Internal Settings: Notes and Observations

We can see that increasing the step size and number of steps in the displacement algorithm decreases the number of diffuse reflection fallbacks without a noticeable impact on the per-event runtime (the variations shown are due to cluster file system issues)

We can attribute a majority of the computation time to the different custom functions used in the edge finding algorithm (used for reflections against the Z-surfaces on the curved sidewalls)

The number of diffuse reflections continues to decrease as the step limit is increased, but remains relatively constant after 3000 steps:

- Ranges from 68-43 diffuse reflections for 3000 5000 steps
- Average: 58.44 +/- 8.23

Summary and Conclusions

The simplified surface mode model is working as expected! We have shown a variety of edge cases, such as reflecting against the Z-surfaces and skipping across the detector flats

The number of diffuse reflections can be further reduced by increasing the number of steps that we take around the detector in the displacement algorithm

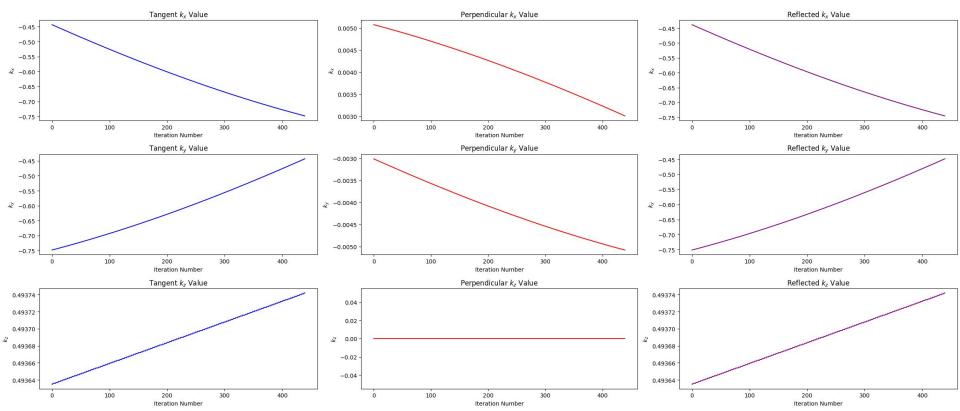
Two custom classes were created as part of this work that could be useful for future G4CMP development: **G4CMPSolidUtils** and **ParticleChangeForPhonon**

The remaining tasks are underway:

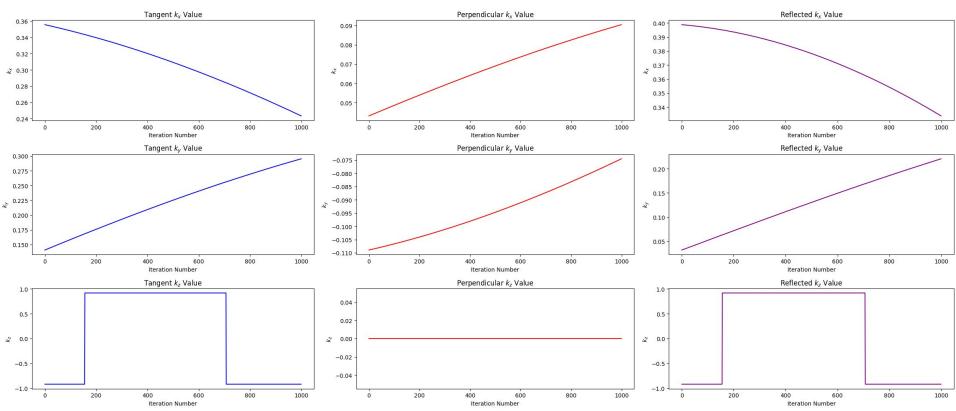
- Probability of Specular vs Diffuse reflections (Rik B. @ A&M for CDMSlite)
- Final code review for merging 317 onto develop

Backup Slides

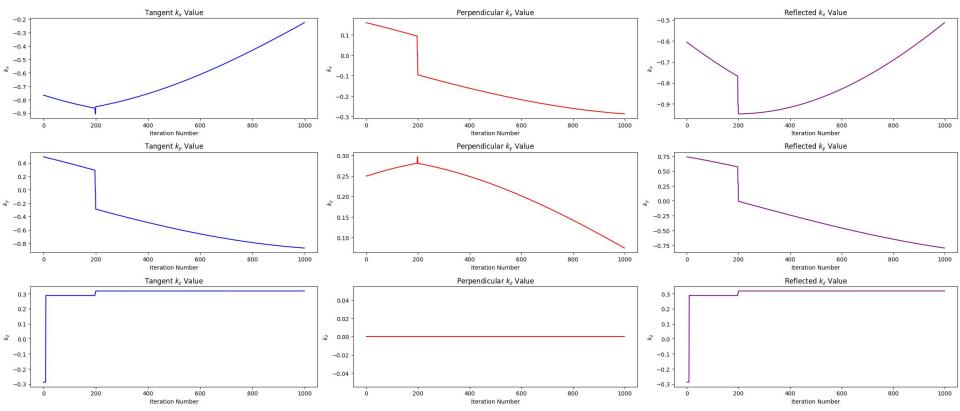
Individual Phonon - Wave vector (Simple)



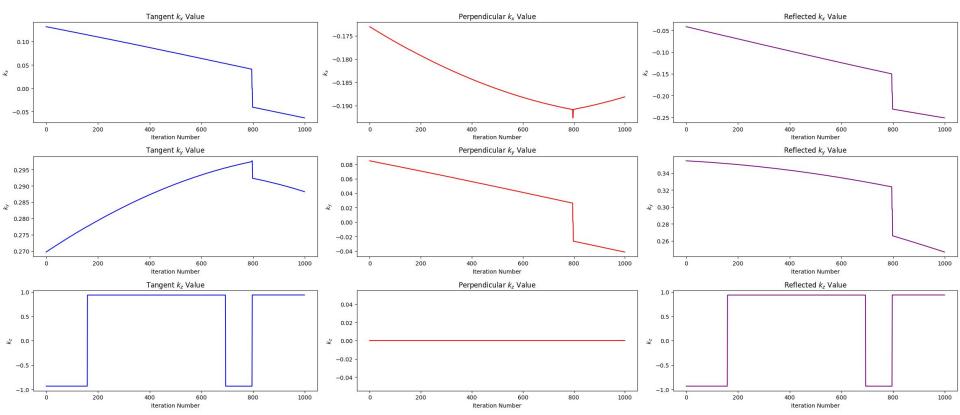
Individual Phonon - Wave vector (Edge Reflection)



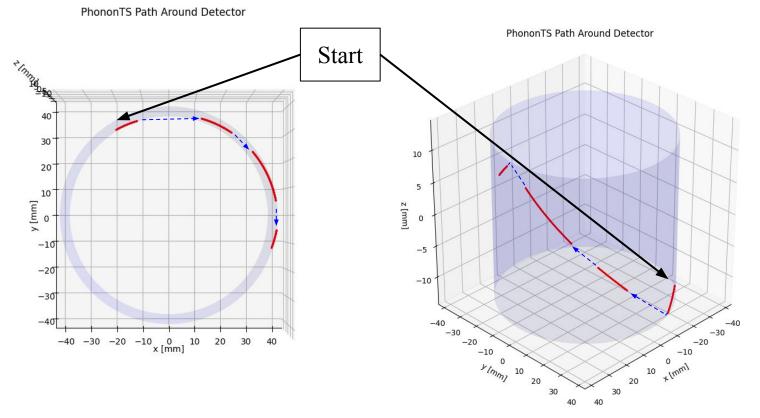
Individual Phonon - Wave vector (Skip Flats)



Individual Phonon - Path Around Detector (Skip Flats + Edge Reflection)



Failed Reflection - Long Arclength



These are scatter plots - The gap is due to the displacement across the flat taking 0 steps

Initial High Level Results \rightarrow G4CMP-480

Collection Efficiency: 100%

Number of diffuse reflections:

Job 0: 15779

Job 1: 13659

Job 2: 15498

Job 3: 18651

Job 4: 17802

Total: 81,389

Diffuse reflections per event: 814

Rotated Detector (120 deg):

Collection Efficiency: 100%

Number of diffuse reflections:

Job 0: 25217

Job 1: 23570

Job 2: 28885

Job 3: 26587

Job 4: 28836

Total: 133,095

Diffuse reflections per event: 1331

Displaced Detector:

Collection Efficiency: 100%

Number of diffuse reflections:

Job 0: 13400

Job 1: 13311

Job 2: 17989

Job 3: 16416

Job 4: 18897

Total: 80,013

Diffuse reflections per event: 800

High Level Results (After G4CMP-480)

Single	Detector:
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Collection Efficiency: 100%

Number of diffuse reflections:

Job 0: 14798

Job 1: 14835

Job 2: 20441

Job 3: 17423

Job 4: 17226

Total: 84723

Diffuse reflections per event: 848

Rotated Detector (120 deg):

Collection Efficiency: 100%

Number of diffuse reflections:

Job 0: 14582

Job 1: 16932

Job 2: 14554

Job 3: 12468

Job 4: 15812

Total: 74348

Diffuse reflections per event: 744

Displaced Detector:

Collection Efficiency: 100%

Number of diffuse reflections:

Job 0: 14137

Job 1: 19684

Job 2: 18008

Job 3: 18391

Job 4: 18897

Total: 89117

Diffuse reflections per event: 892

High Level Results (After G4CMP-480)

Collection Efficiency: 100%

Number of diffuse reflections:

Job 0: 14798

Job 1: 14835

Job 2: 20441

Job 3: 17423

Job 4: 17226

Total: 84723

Diffuse reflections per event: 848

Rotated & Displaced Detector:

Collection Efficiency: 100%

Number of diffuse reflections:

Job 0: 20253

Job 1: 14898

Job 2: 21722

Job 3: 13573

Job 4: 16061

Total: 86507

Diffuse reflections per event: 866